## **3.46 PHOTONIC MATERIALS AND DEVICES**

Homework Assignment 4—March 1, 2006 Due: 5pm, March 8, 2006

## 1. Photonic Crystals

Calculate the penetration depth x and stopband width  $\Delta\lambda$  for  $\lambda$  = 1.55 µm light incident on a 1D photonic crystal (with films thickness following the  $\lambda$ /4n criterion) made of:

- a) Si and SiO<sub>2</sub> pairs
- b)  $Si_3N_4$  and  $SiO_2$  pairs
- c) Si and Si<sub>3</sub>N<sub>4</sub> pairs ( $n_{Si} = 3.5, n_{Si3N4} = 2.0, n_{SiO2} = 1.445$ )

## 2. Resonant Cavity (read more about 'mirror loss' in Fundamentals of Photonics)

A linear microcavity resonator of size d is bounded on either end by a Bragg Reflector with reflectivity R (at  $\lambda = 1.55 \ \mu$ m). When a pulse of light transits across the microcavity and reflects off a Bragg Reflector, it loses some power. We can define a loss coefficient  $\alpha_m$ , called the 'mirror loss,' which renormalizes reflector loss, per unit length of the cavity. Derive the following expression for mirror loss:

$$\boldsymbol{\alpha}_{m} = \frac{1}{d} ln \! \left( \frac{1}{R} \right)$$

Given a group velocity  $v_g$  for the light pulse, and assuming there are no other loss mechanisms inside the microcavity, derive an expression relating the microcavity Quality factor Q to  $\alpha_m$ . The peak reflectivity at a Bragg Reflector stopband's central frequency can be derived as a function of reflector indices  $n_L$ ,  $n_H$  and number of low/high index pairs p:

$$\mathsf{R} = \left| \frac{(\mathsf{n}_{\rm L} / \mathsf{n}_{\rm H})^{2p} - \mathsf{n}_{\rm H}^{2}}{(\mathsf{n}_{\rm L} / \mathsf{n}_{\rm H})^{2p} + \mathsf{n}_{\rm H}^{2}} \right|^{2}$$

Using all of the above relationships, determine what the resonance linewidth  $\Delta\lambda$  will be for a SiO<sub>2</sub> microcavity (n = 1.445) designed to trap the first mode of  $\lambda$  = 1.55 µm light, entering at normal incidence (the propagation wavevector  $\beta$  lies fully along the z-axis direction of propagation). The cavity is bounded on either end by Bragg Reflectors made up of 3 pairs of Si/Si<sub>3</sub>N<sub>4</sub> (Si3N4 is the layer in physical contact with the SiO<sub>2</sub> microcavity on either end). The Si/Si<sub>3</sub>N<sub>4</sub> layers should be designed to meet the  $\lambda$ /4n condition. State what all your assumed film thickness values are.



## 3. Ring Resonator (dB/cm definition given in *Fundamentals of Photonics*)

If you have a single mode microring resonator ( $n_1 = 1.445$ ,  $n_2 = 3.5$ ,  $n_{eff} = 2.2$ ), with  $r = 5.04 \ \mu$ m and operating wavelength at 1.55  $\mu$ m:

- a) What is the quality factor if the loss of the ring is 100 dB/cm? How about 10 dB/cm?
- b) What is the 3 dB bandwidth if the loss of the ring is 100 dB/cm? How about 10 dB/cm?

If you want to achieve a 1 nm tuning range:

c) What is the radius change you need to have? What is the refractive index change you need to have?